

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: K. TOSHIYASU, et al.

Application No.: Rule 1.53(b) Divisional of U.S. Patent Application Serial No. 10/111,231, filed April 23, 2002

Filed: On Even Date Herewith

For: ADHESIVE FILM FOR SEMICONDUCTOR, LEAD FRAME AND SEMICONDUCTOR DEVICE USING THE SAME, AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

Art Group of Parent: 2827

Examiner of Parent: D. A. Zarneke

**CLAIM FOR PRIORITY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

December 15, 2003

Sir:

Pursuant to 35 U.S.C. § 119 and 37 C.F.R. § 1.55, Applicants hereby claim the right of priority based on the following foreign application filed in Japan:

Application No. JP 11-320301, filed November 10, 1999.


A copy of the certified copy of the above-identified Japanese Patent Application has been received in the U.S. Patent and Trademark Office in National Stage Application No. 10/111,231, filed on April 23, 2002, as indicated by the Examiner in the Notice of Allowability enclosed with the Notice of Allowance and Fee(s) Due mailed September 4, 2003.

Docket No.: 523.41628VX1

Kindly charge any additional fees due, or credit overpayment of fees, to the  
Antonelli, Terry, Stout & Kraus, LLP Deposit Account No. 01-2135 (523.41628VX1).

Respectfully submitted,

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